IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazufumi SATO et al. :

Serial No. NEW : Attn: APPLICATION BRANCH

Filed November 20, 2003 : Attorney Docket No. 2003 1687

POSITIVE-WORKING PHOTORESIST COMBINATION (Rule 1.53(b) Divisional of Serial No. 10/114,258, Filed April 3, 2002)

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-74097, filed March 18, 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 10/114,258, filed April 3, 2002.

Respectfully submitted,

Kazufumi SATO et al.

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